



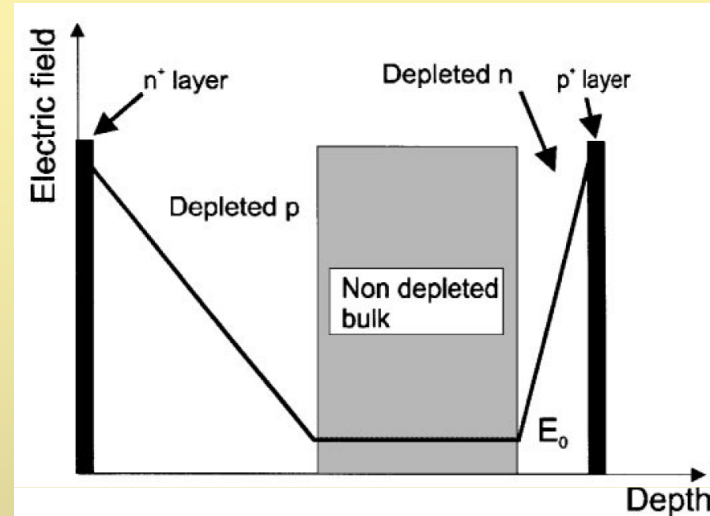
UNIVERSITY OF  
LIVERPOOL

# **Studies on Charge Collection Efficiencies for Planar Silicon Detectors after Doses up to $10^{16}$ $n_{eq}/\text{cm}^2$ and the Effect of Varying Substrate Thickness**

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# N-side read-out for tracking in high (SLHC levels: $1-2 \times 10^{16} \text{ cm}^{-2}$ ) radiation environments?

Schematic changes of Electric field after irradiation



Effect of trapping on the Charge Collection Efficiency (CCE)

$$Q_{tc} \cong Q_0 \exp(-t_c / \tau_{tr}), \quad 1/\tau_{tr} = \beta \Phi.$$

Collecting electrons provide a sensitive advantage with respect to holes due to a much shorter  $t_c$ . P-type detectors are the most natural solution for  $e^-$  collection on the segmented side.

N-side read out to keep lower  $t_c$

## Effect of trapping on the Charge Collection Distance

After heavy irradiation the charge collection distance (CCD) of thin detectors should have a similar (better?) charge collection efficiency (CCE) as thicker ones.

$$Q_{tc} \cong Q_0 \exp(-t_c/\tau_{tr}), 1/\tau_{tr} = \beta\Phi.$$

$$v_{sat,e} \times \tau_{tr} = \lambda_{av}$$

$$\beta_e = 4.2E-16 \text{ cm}^2/\text{ns}$$

$$\beta_h = 6.1E-16 \text{ cm}^2/\text{ns}$$

G. Kramberger et al.,  
NIMA 476(2002), 645-  
651.

$$\lambda_{av} (\Phi=1e14) \cong 2400\mu\text{m}$$

$$\lambda_{av} (\Phi=1e16) \cong 24\mu\text{m}$$

The reverse current is proportional to the depleted volume in irradiated detectors. Do thin sensors offer an advantage in term of reduced reverse current compared to thicker ones (this aspect is particularly important for the inner layer detectors of SLHC, where significant contribution to power consumption is expected from the sensors themselves)?

# Silicon miniature microstrip detectors and irradiation

**RD50 mask set** (see: <http://rd50.web.cern.ch/rd50/>)

Miniature sensors,  $\sim 1 \times 1 \text{ cm}^2$ , 128 strips, 80  $\mu\text{m}$  pitch, designed by Liverpool and produced by Micron on 300 $\mu\text{m}$  and 140 $\mu\text{m}$  thick wafers.

Irradiation and dosimetry:

**Neutron:**

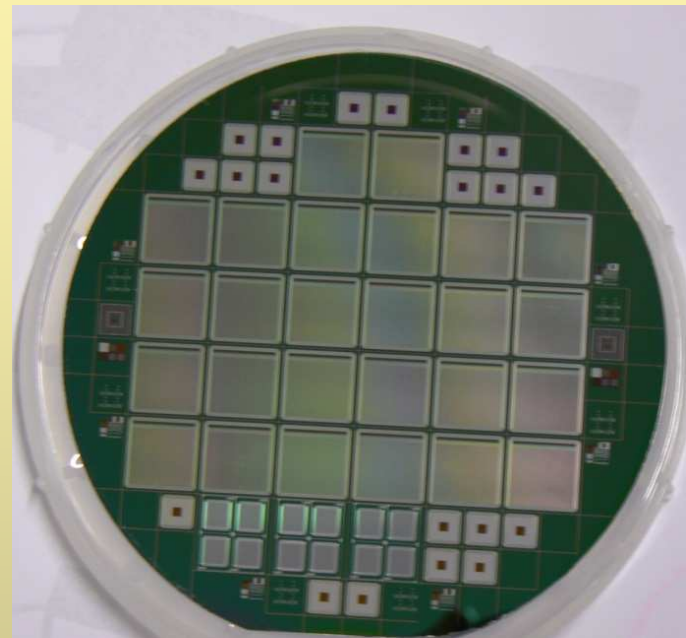
TRIGA Mark II research reactor  
Reactor Centre of the  
[Jozef Stefan Institute, Ljubljana,](#)  
Slovenia

**24 GeV protons:**

[CERN-PS Irrad1](#) (M. Glaser)

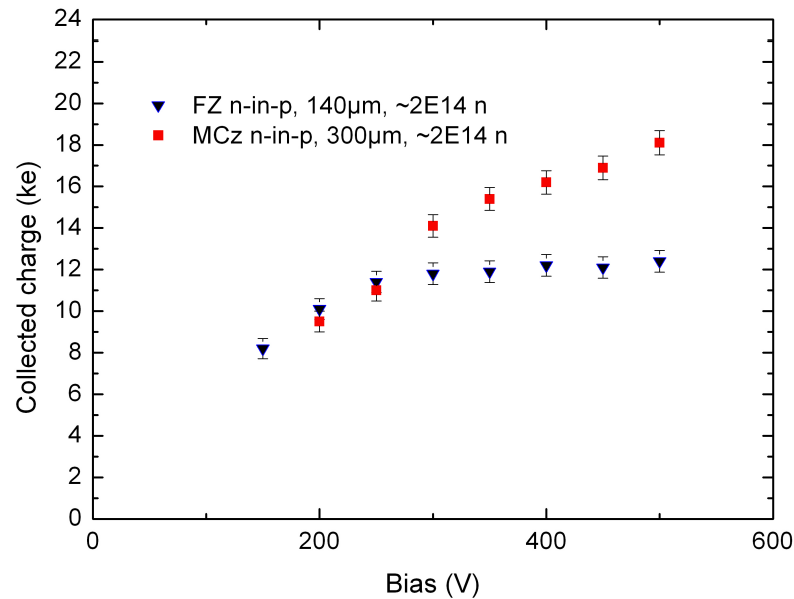
**26 MeV protons:**

Compact Cyclotron of the University of  
Karlsruhe (W. de Boer)

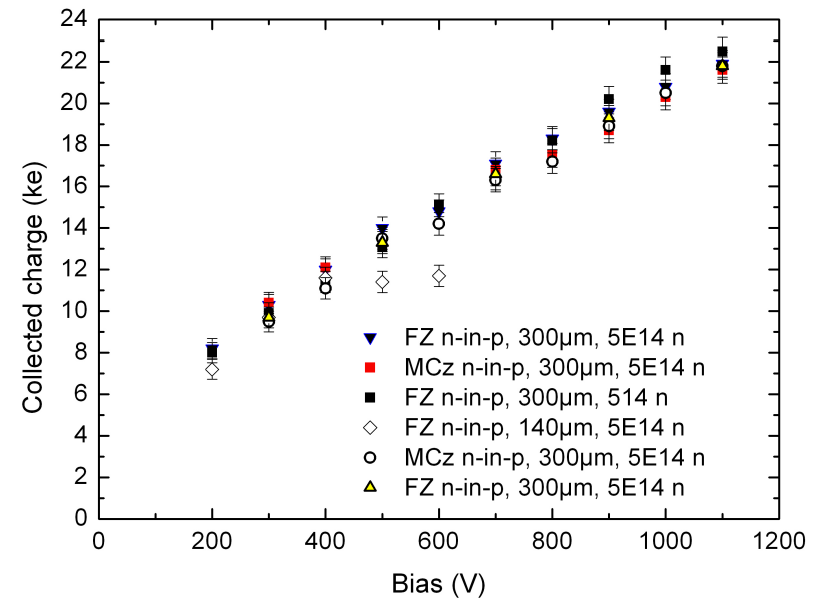


## Changes of the CCD: comparison of thin and thick detectors after 2 and $5 \times 10^{14}$ n cm<sup>-2</sup>.

After  $2 \times 10^{14}$  n cm<sup>-2</sup>, same CCE at low voltages and than saturation for the thin sensor (~250V).

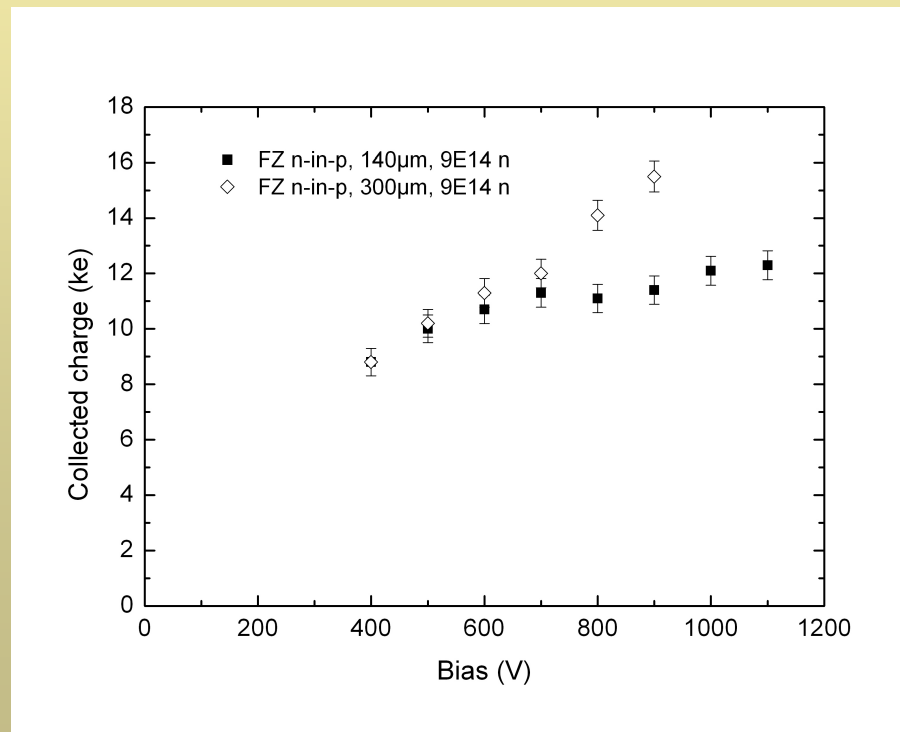


After  $5 \times 10^{14}$  n cm<sup>-2</sup>, same CCE at low voltages and than saturation for the thin sensor (~400V).



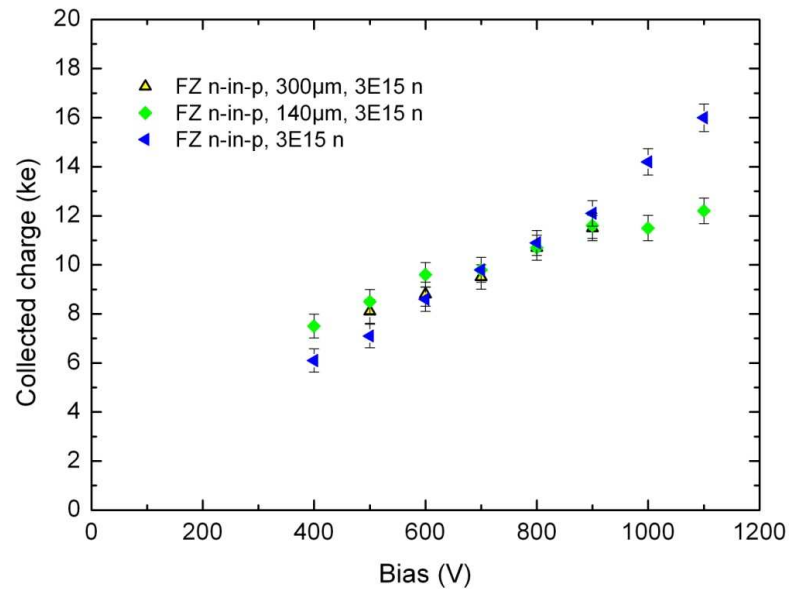
## Changes of the CCD: comparison of thin and thick detectors after $1 \times 10^{15} \text{ n cm}^{-2}$ .

After  $1 \times 10^{15} \text{ n cm}^{-2}$ , saturation for the thin sensor ( $\sim 600\text{V}$ ).

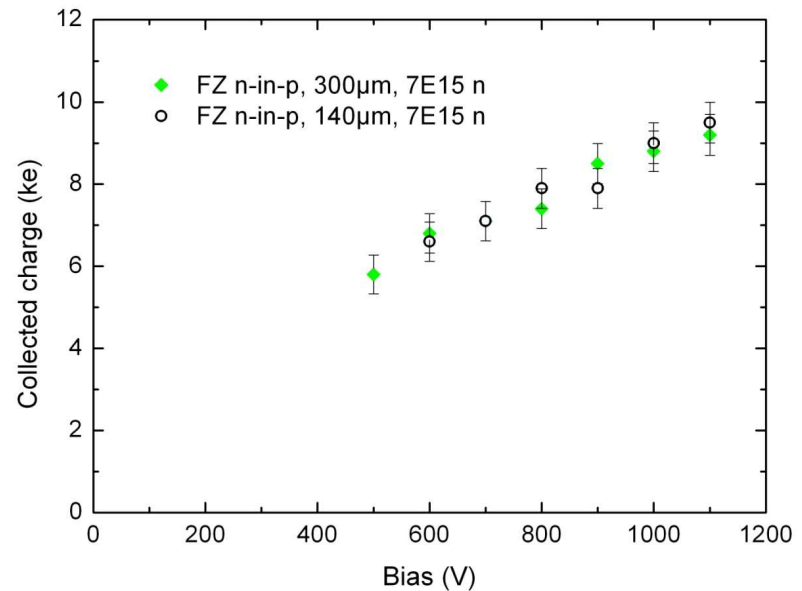


## Changes of the CCD: comparison of thin and thick detectors after 3 and $7.5 \times 10^{15}$ n cm<sup>-2</sup>.

After  $3 \times 10^{15}$  n cm<sup>-2</sup> the CCE of the 300 $\mu$ m thick devices becomes higher above 900V.

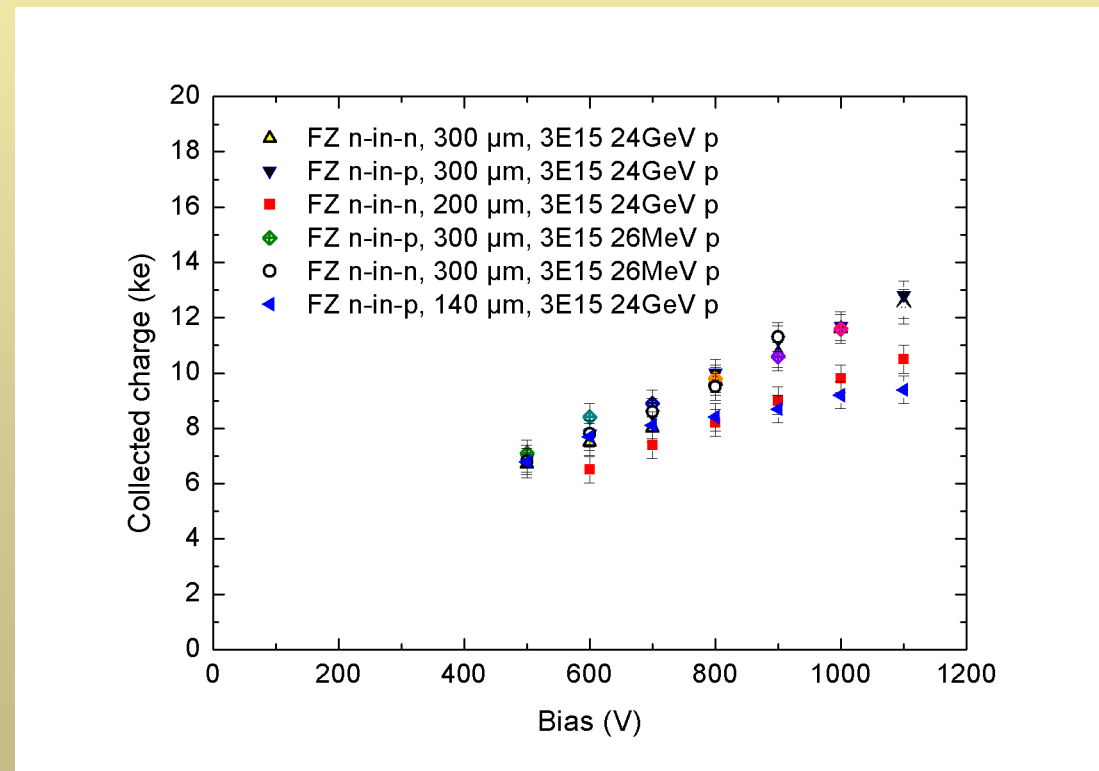


After  $7.5 \times 10^{15}$  n cm<sup>-2</sup> the CCE of thin and thick sensors is the same up to 1100V.



## Changes of the CCD: comparison of thin and thick detectors after $3 \times 10^{15}$ 26MeV and 24GeV p $\text{cm}^{-2}$ .

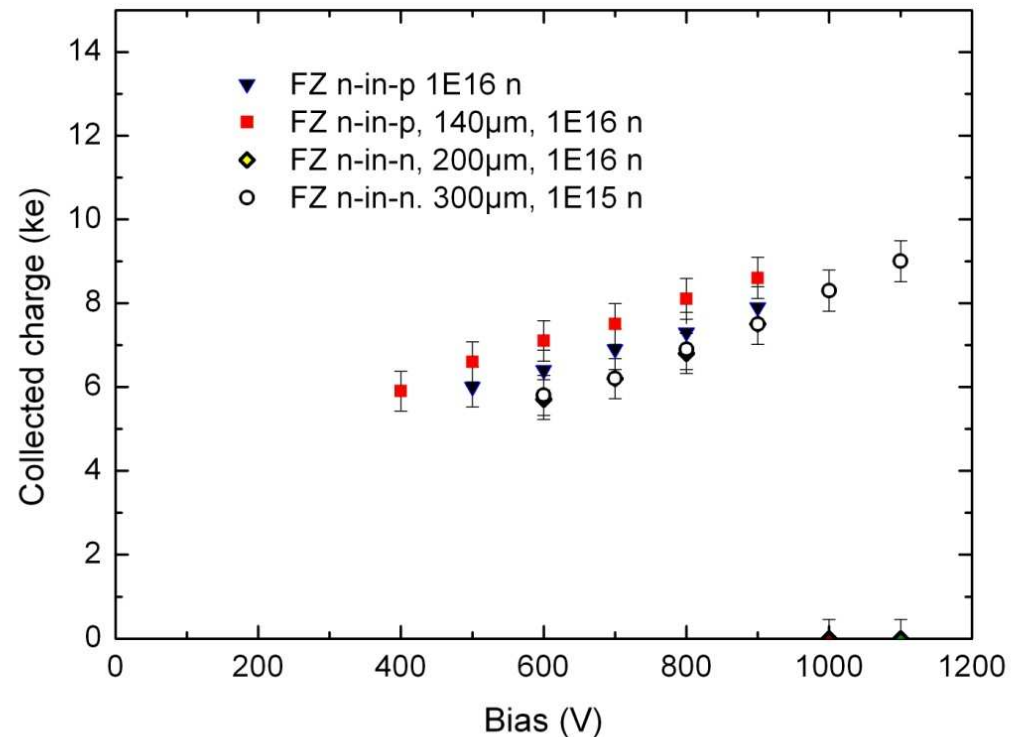
After  $3 \times 10^{15}$   $n_{\text{eq}}$   $\text{cm}^{-2}$  the CCE of the 300 $\mu\text{m}$  thick devices becomes higher above 700V.





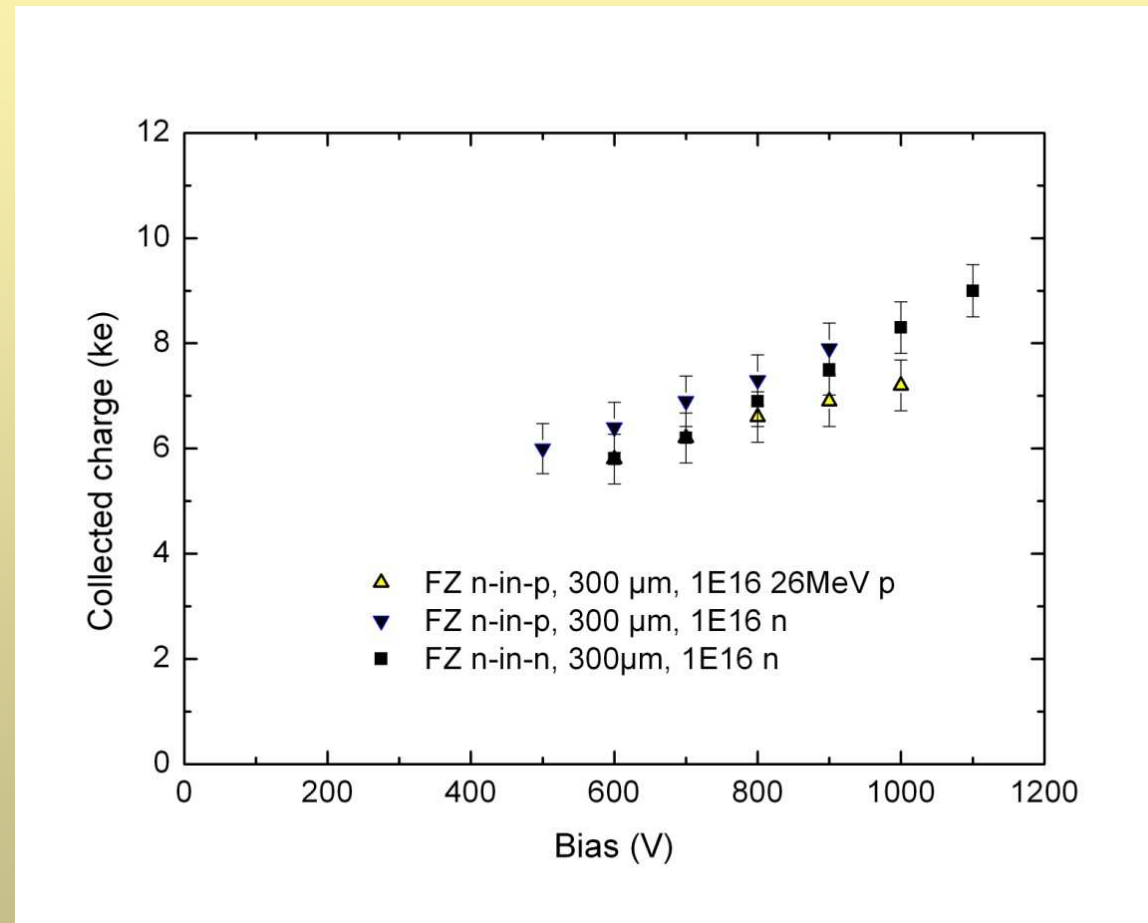
## 140, 200 and 300 $\mu\text{m}$ thick detectors after $\sim 1 \times 10^{16} \text{ n cm}^{-2}$ !

About 10% higher  
CCE for the 140 $\mu\text{m}$   
thick sensors  
(irradiated in the  
same session as the  
300  $\mu\text{m}$  thick one).



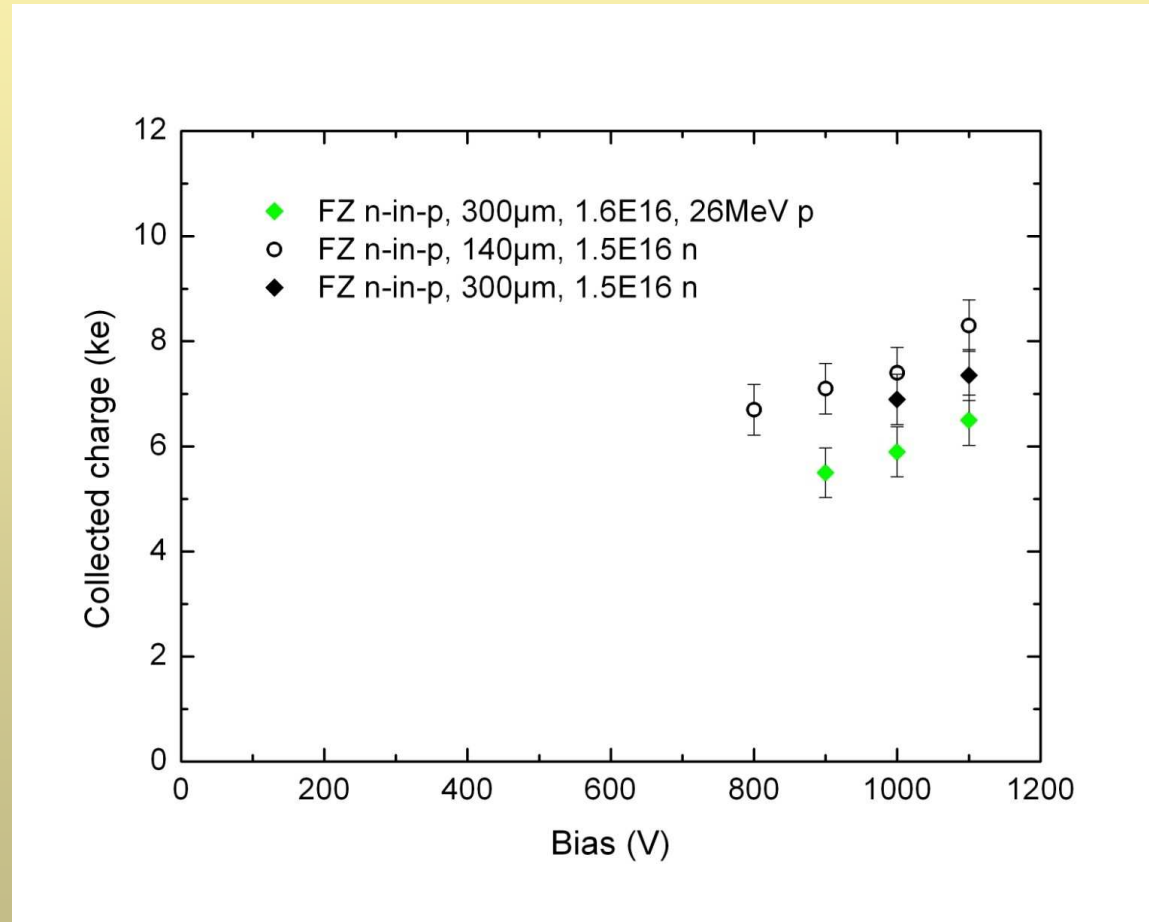
## 300 $\mu\text{m}$ thick n-in-n and n-in-p detectors after $\sim 1 \times 10^{16}$ n and 26MeV p $\text{cm}^{-2}$ !

Indication that proton introduces more charge trapping than neutron irradiation for equivalent NIEL doses. Similar CCE vs Bias(V) for n-side read out n and p FZ substrates.



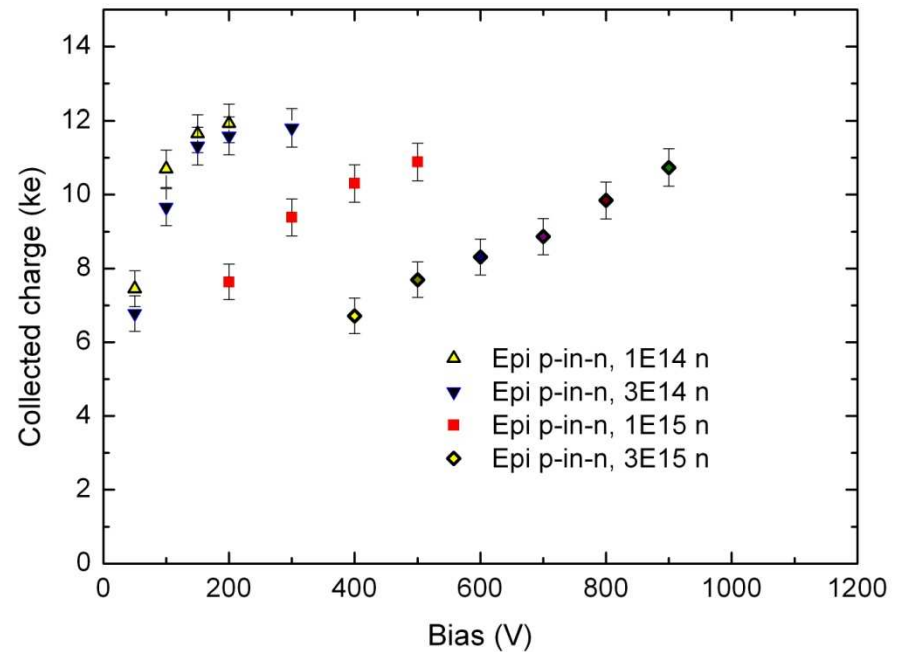
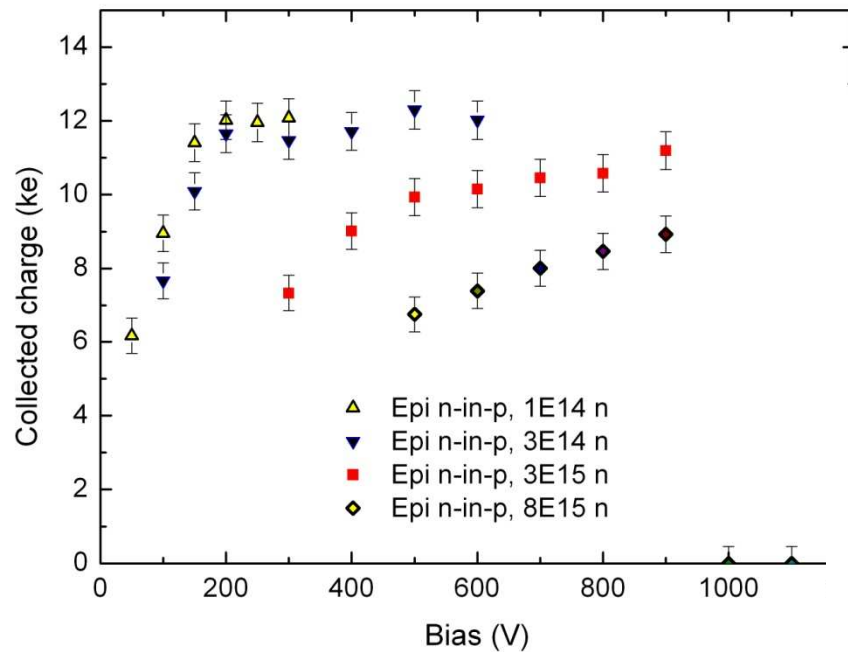
## 140 and 300 $\mu\text{m}$ thick detectors after $\sim 1.5 \times 10^{16}$ n and 26MeV p $\text{cm}^{-2}$ !

Evidence that proton introduces more charge trapping than neutron irradiation for equivalent NIEL doses.

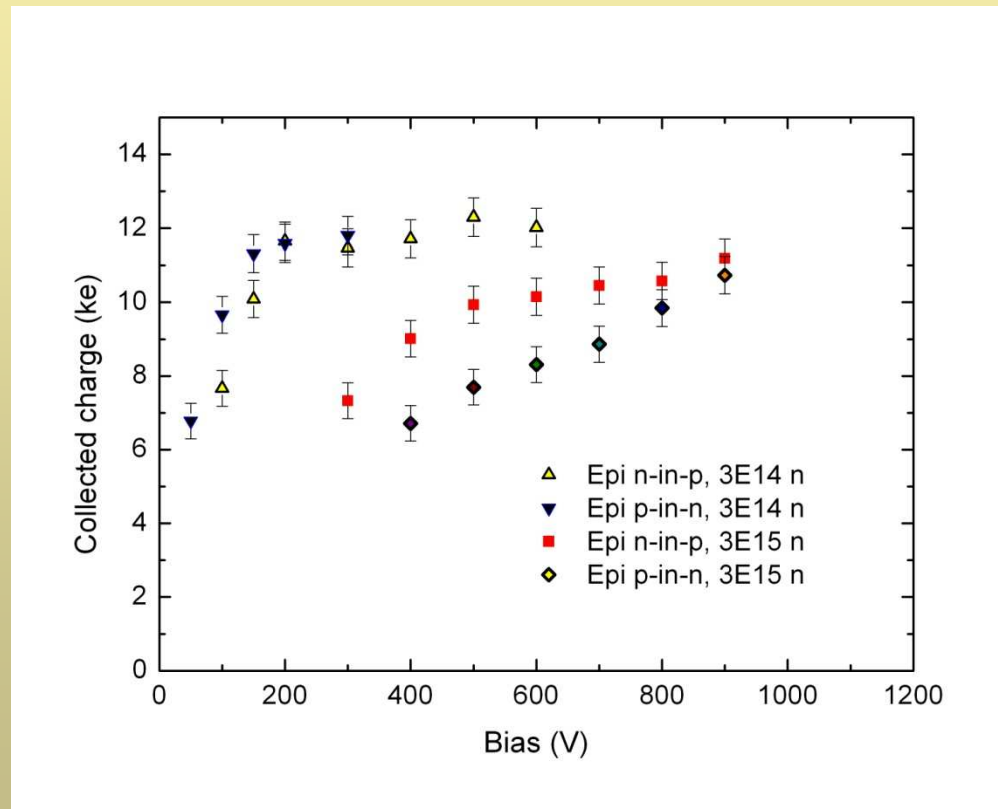


# Material comparison: EPI n and p (150 $\mu\text{m}$ ) reactor neutrons

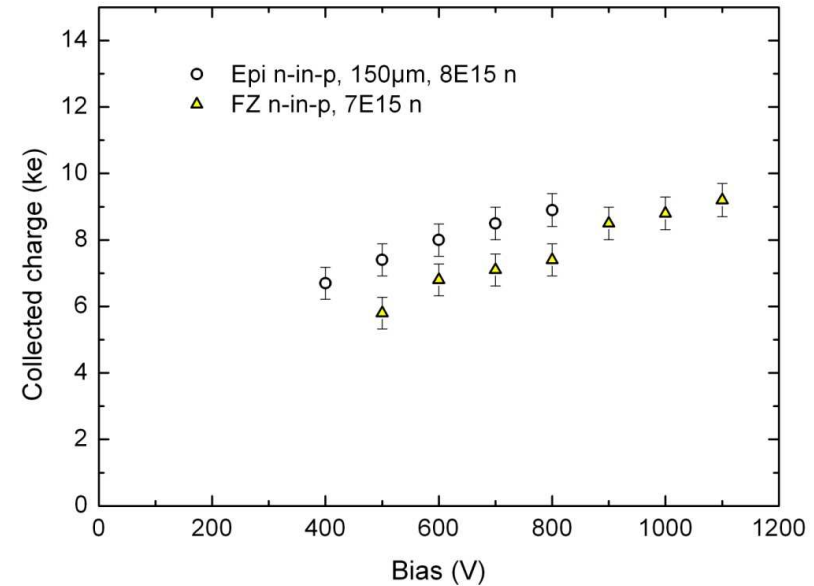
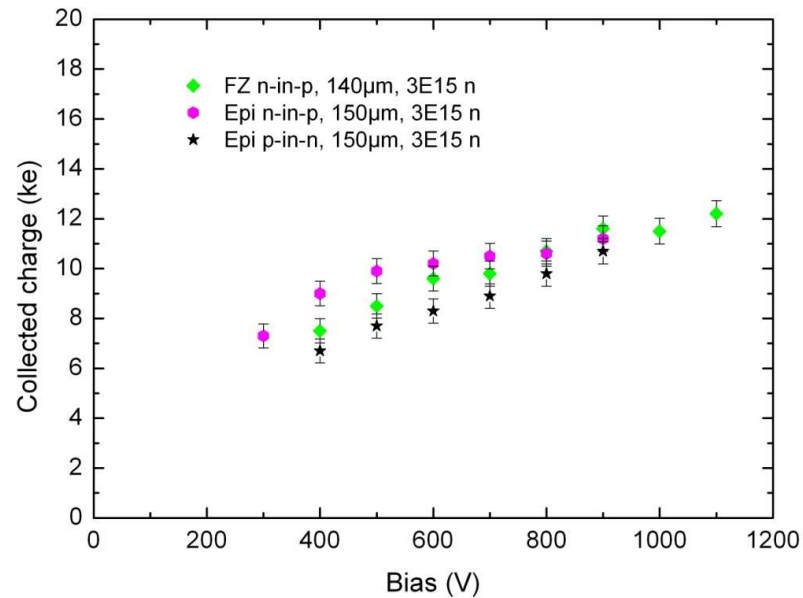
Produced by CNM Barcelona



# Material comparison: EPI n vs p, reactor neutrons

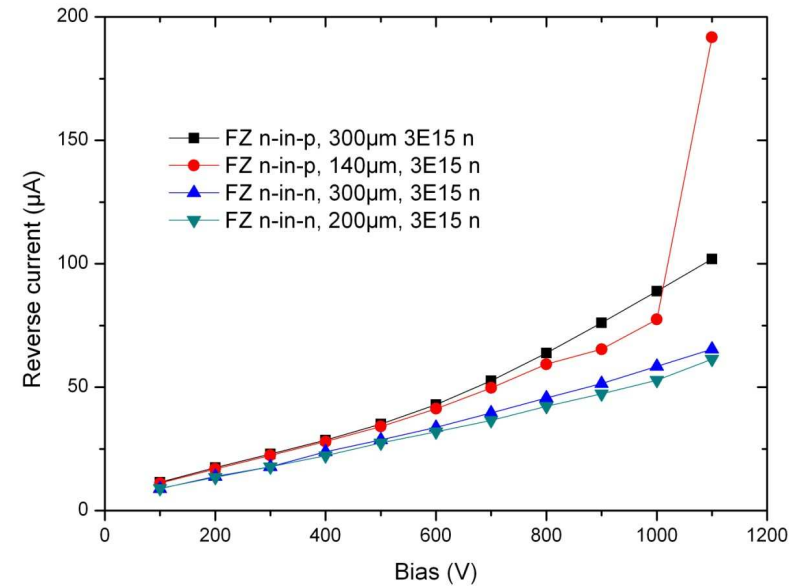
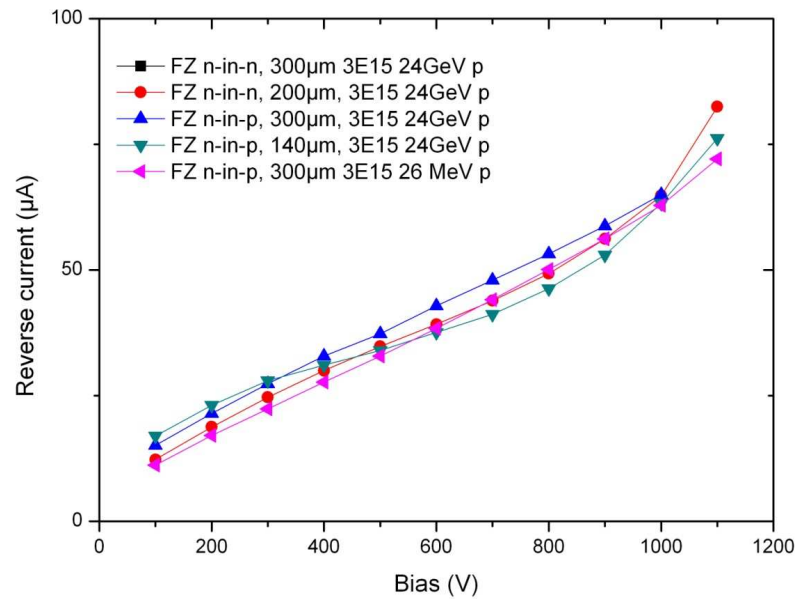


# Material comparison: EPI vs FZ, reactor neutrons

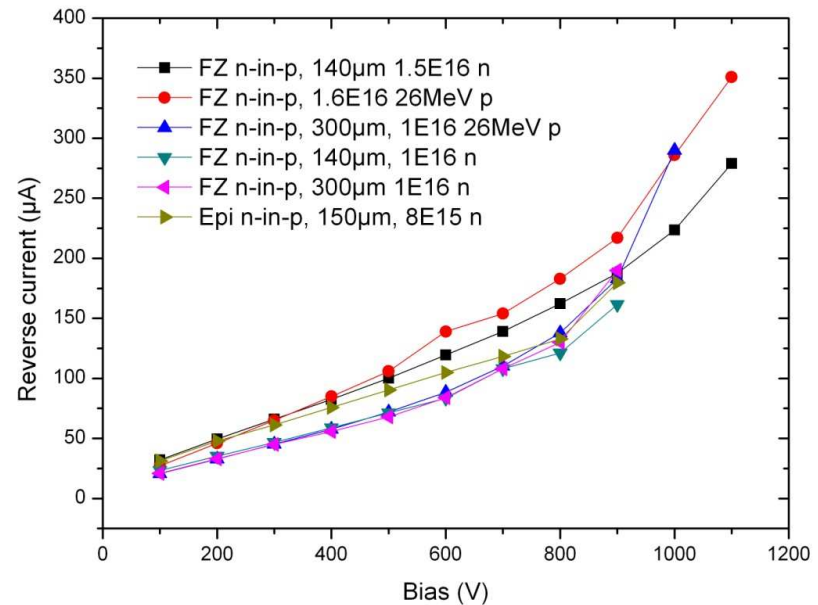
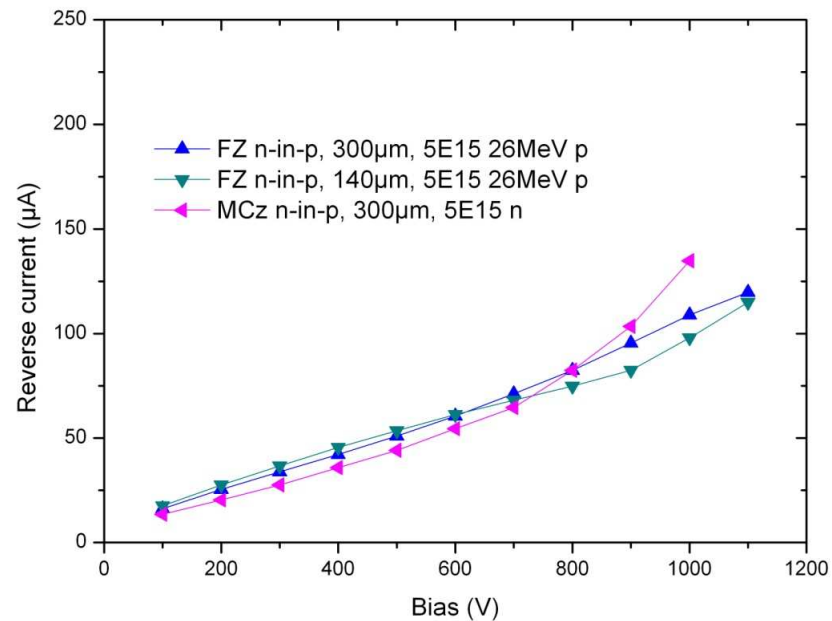


Good CCE results with Epi! Drawbacks: difficult to process, expensive, limited sources of thick Epi (150 $\mu$ m), possible variability of performances!

# IV thin vs standard, various irradiation



# IV thin vs standard, various irradiation





# CONCLUSIONS:

The comparison of 140 and 300 $\mu\text{m}$  thick Si sensors shows that after hadron irradiation doses between 3 and  $7 \times 10^{15} \text{ n cm}^{-2}$  the CCD in silicon becomes smaller than 140 $\mu\text{m}$ , at least up to bias voltages up to 1100V. Thin and thick detectors show essentially the same CCE (with a possible 10% higher CCE for the thin ones after doses  $> 10^{16} \text{ cm}^{-2}$ ).

Evidence of more charge carrier trapping introduced by proton with respect to neutron irradiation is found with CCE measurements at high doses. Comparison of thin and thick devices with charged particle irradiation will tell if a more consistent advantage is found with thin devices in this case.

After heavy neutron irradiations the CCE of thin and thick detectors becomes similar. The choice of optimal thickness can be dictated by the need of reducing the detector mass rather than increase of the signal after irradiation (at least up the remarkable dose of  $1 \times 10^{16} \text{ n cm}^{-2}$ !!).